



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
(Attorney Docket No. 100045)

Applicant(s): Cherian et al.

Serial No.: 10/073,844

Filing Date: February 11, 2002

For: ANIONIC ABRASIVE PARTICLES
TREATED WITH POSITIVELY
CHARGED POLYELECTROLYTES
FOR CMP

Examiner: Not yet known

Group Art Unit: 1755

CERTIFICATE OF MAILING

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SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Applicant(s) submit(s) a completed form PTO/SB/08A listing documents cited in a communication received from the International Searching Authority in connection with a patent application corresponding to this matter not more than three months prior to the filing of this statement. Copies of the listed documents are enclosed. The Examiner is requested to review these documents and to determine the extent of the materiality of the document disclosures, if any, with respect to the present invention.

The right to later set forth how the claimed invention is distinguished over the disclosure of any document or other art, including the disclosures of the art and documents referenced herein, and those that may be cited by the Examiner in rejecting a claim in the instant patent application is reserved.

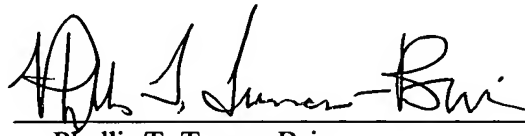
The referenced documents are cited to ensure that the Examiner has the benefit of all the information of which the Applicants are aware which may be helpful to the U.S. Patent and Trademark Office in its examination of this application. The Examiner is requested to review the documents and determine the extent of materiality of the disclosures with respect to the present invention.

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As this paper is being timely submitted, no fees are believed to be due. However, this authority is hereby authorized to charge any deficiency or credit any overpayment in connection with this filing to Deposit Account No. 501599.

Respectfully submitted,

Date: June 18, 2003



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U.S. Patent and Trademark Office: U.S. DEPARTMENT OF COMMERCE

Comparable to Form PTO/SB/08A

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

**Complete if Known**

Application Number:	10/073,844
Filing Date:	11 FEB 02
First Named Inventor:	CHERIAN
Art Unit:	1755
Examiner Name:	Not yet known
Atty. Docket No.:	100045

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JUN 26 2003
TC 1700

U.S. PATENT DOCUMENTS

Examiner Initials	Cite No.	Document Number Number-Kind Code (if known)	Publication Date	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines Where Relevant Passages Or Figures Appear

FOREIGN PATENT DOCUMENTS

Examiner Initials	Cite No.	Foreign Patent Document Country Code-Number-Kind Code (if known)	Publication Date	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines Where Relevant Passages Or Figures Appear	T
	1.	WO 01 12740 A1	Feb. 22, 2001	Wang et al.		

OTHER DOCUMENTS (NON-PATENT LITERATURE DOCUMENTS)

Examiner Initials	Cite No.	Author's NAME, title of the article, book, magazine, journal, serial, symposium, catalog, etc., date, page(s), volume-issue number(s), publisher, city and/or country of publication	T
	2.	MCNAMEE, C.E. et al: Adsorption of quarternarised polyvinylpyridine and subsequent counterion binding of perfluorinated anionic surfactants on silica as a function of concentration and pH: a zeta potential study" COLLOIDS AND SURFACES, A: PHYSICOCHEMICAL AND ENGINEERING ASPECTS (2001), 193, 175-185	
	3.	SCHWARZ, S. et al: "Polyelectrolyte adsorption on charged surfaces: study by electrokinetic measurements" COLLOIDS AND SURFACES, A: PHYSICOCHEMICAL AND ENGINEERING ASPECTS (1998), 140(1-3), 377-384	
	4.	SCHWARZ, S. et al: "Adsorption and stability of colloidal silica" COLLOIDS AND SURFACES, A: PHYSICOCHEMICAL AND ENGINEERING ASPECTS (2000), 163(1), 17-27	

Examiner's Signature:

Date Considered: